

Abstract Topological insulators are states of quantum matter that have narrow topological nontrivial energy gaps and a large third-order nonlinear optical response. The optical absorption of topological insulators can become saturated under strong excitation. In this work, with Bi_2Se_3 as an example, it was demonstrated that a topological insulator can modulate the operation of a bulk solid-state laser by taking advantage of its saturable absorption. The result suggests that topological insulators are potentially attractive as broadband pulsed modulators for the generation of short and ultrashort pulses in bulk solid-state lasers, in addition to other promising applications in physics and computing.

LETTER
ARTICLE

Topological insulator as an optical modulator for pulsed solid-state lasers

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1. Introduction

Topological insulators are novel quantum electronic materials whose edge modes have exotic spin and charge properties [1–4]. At an edge or on a surface, the metallic state appears and is protected by the topological symmetry, such as time-reversal or crystalline symmetry [5, 6], which generates a bulk gap and an odd number of relativistic Dirac fermions on the surface [7]. Therefore, topological insulators behave as insulators in their interior but their surfaces contain metallic states [8]. These states allow electrons to travel on the surface of the material at room temperature, an effect that has promising applications in computing [9]. In recent years, exotic properties, including spin-orbit coupling, the quantum spin Hall effect, dissipationless spin current and the magnetoelectric effect have been investigated [4, 10–13]. A topological insulator has a single Dirac cone on the surface around the Γ point and a gap of 0.2–0.3 eV in the bulk [2, 14]. Thus, a topological insulator should also exhibit saturable absorption effect because of its narrow gap [15, 16], which means that, under weak excitation, the linear absorption of light dominates, while under strong excitation, the nonlinear absorption occurs. Based on the photoelectric effect, both the surface and bulk can absorb light and reach saturation under strong excitation when

the wavelength of the incident light is shorter than 4.1 μm (0.3 eV).

The saturable absorption of many well-known saturable absorbers, including Cr:YAG, semiconductor saturable absorber mirrors (SESAM), and GaAs, are wavelength sensitive. Recently, single-walled carbon nanotubes have also been used as saturable absorbers depending on diameter selectivity and benefiting from the presence of small bundles. The diameter of a single-walled carbon nanotube controls its bandgap. Broadband absorption becomes possible by using carbon nanotubes with a broad diameter distribution [15, 17]. The performance of a mode-locked fiber laser with a topological insulator saturable absorber has been studied [17]. In contrast to fiber lasers, which have large gain, the diode-pumped solid-state bulk lasers (DPSSBLs), including crystalline, ceramic and glass lasers, have a relatively low gain and represent another research regime [18]. Up to now, the pulse DPSSBLs have been applied in many fields, such as industry, medicine, military applications, and basic scientific research, where compact, reliable, and cost-effective pulse lasers are required. Investigation on the possibility of using topological insulators as an optoelectronic device in DPSSBLs is attractive. In this paper, with Bi_2Se_3 as an example, we report on the investigation of a DPSSBL modulated by a topological insulator. The results

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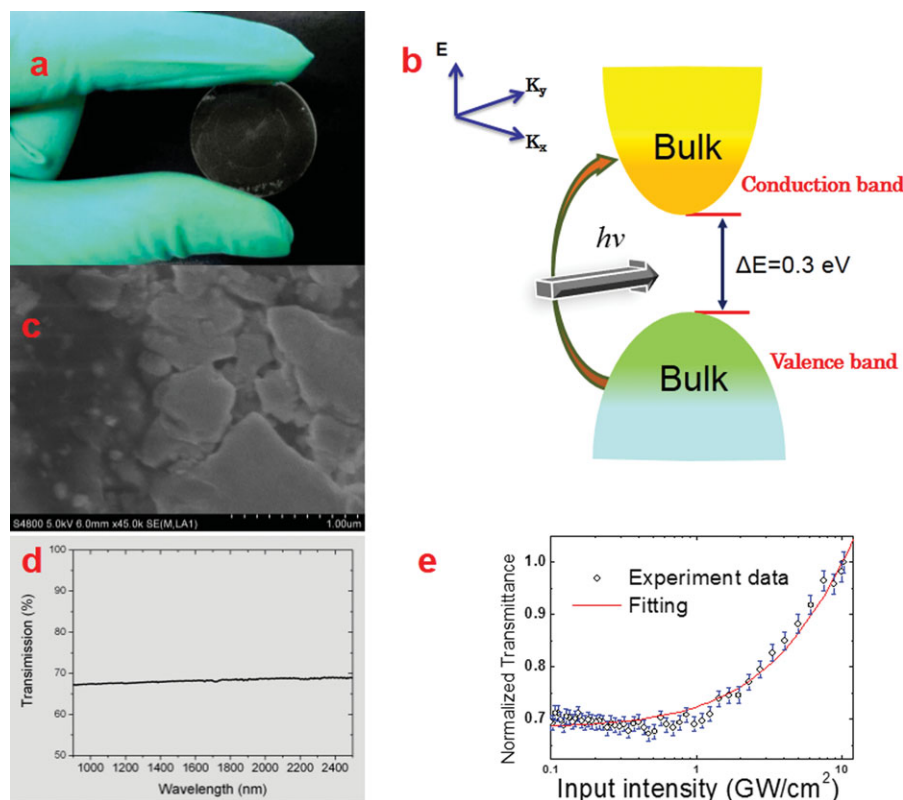


Figure 1 (a) Photograph of topological insulator Bi₂Se₃ sample on quartz substrate. (b) Simple schematic of excitation process responsible for light absorption in a topological insulator by considering the $\Delta E = 0.3$ eV gap in the bulk. The orange region indicates the bulk conduction band and the green region indicates the bulk valence band. (c) SEM image of Bi₂Se₃ on quartz substrate. (d) Absorbance of Bi₂Se₃ on quartz substrate. (e) Theoretical (red curve) and experimental (blue rings) power-dependent nonlinear transmittance of Bi₂Se₃ sample.

confirm the feasibility of using topological insulators as a saturable absorber for the generation of short and ultrashort pulses in DPSSBLs.

2. Results and discussion

2.1. Topological insulator modulator

The Bi₂Se₃ topological insulator plates used in the experiments were synthesized via a polyol method. A solution with dispersed Bi₂Se₃ was dropped onto a 1-mm thick quartz plate whose diameter was about 1 inch. The dried plate with the topological insulator on it is shown in Fig. 1a. Previous theoretical studies have shown that the Bi₂Se₃ electronic band structure possesses a one-valley conduction-band minimum and a one-valley valence-band maximum occurring at the center of the Brillouin zone, with a gap of 0.2–0.3 eV in the bulk and zero gap on the surface [19, 20]. When the wavelength of excitation light is shorter than 4.1 μm , corresponding to 0.3 eV per photon, both the surface and the bulk absorb light, and can be saturated under strong excitation. However, when the wavelength of excitation light is longer than 4.1 μm , the single Dirac cone on the surface responds with a nonlinear and saturable absorption. As shown by a previous theoretical calculation [2], the surface bandgap disperses in the bulk gap, and the gaps are almost uninfluenced by each other, in contrast to a traditional semiconductor whose bandgaps

are influenced by the environment. An SEM image of a typical Bi₂Se₃ sample on a quartz substrate is presented in Fig. 1c. From this figure, it is seen that the Bi₂Se₃ plates are randomly distributed on the quartz on a micrometer scale, which indicates that most of the Bi₂Se₃ is in bulk form and the surface states generated on the edges or its surface [2] are relatively rare. Therefore, the linear and nonlinear optical absorption appears as the collective result of the bulk and surface states, and absorption by the Bi₂Se₃ sample can mainly be attributed to the narrow gap in the bulk. Figure 1b shows the excitation process responsible for light absorption in the topological insulator Bi₂Se₃ with a 0.3 eV bulk gap corresponding to a light wavelength of 4.1 μm . A photon can excite an electron from the valence band to the conduction band when the light wavelength is shorter than 4.1 μm . Using the semiconductor two-level model [21], under strong light excitation, electrons from the valence band (green) are excited into the conduction band (orange) and the states in the valence band become depleted, while the final states in the conduction band are partially occupied. Further excitation from the valence band is blocked and no further absorption is induced, leading to a saturable absorption condition [15, 21]. Therefore, low (large) intensity light experiences large (low) loss, and the topological insulator can be used as a saturable absorber. For a short period of time after excitation, intraband phonon scattering and electron–hole recombination relax the photoexcited carriers as in graphene and semiconductor saturable absorbers [15, 21]. Shortly after that, however, the topological insulator absorbs light again. Due to the narrow gap in the bulk,

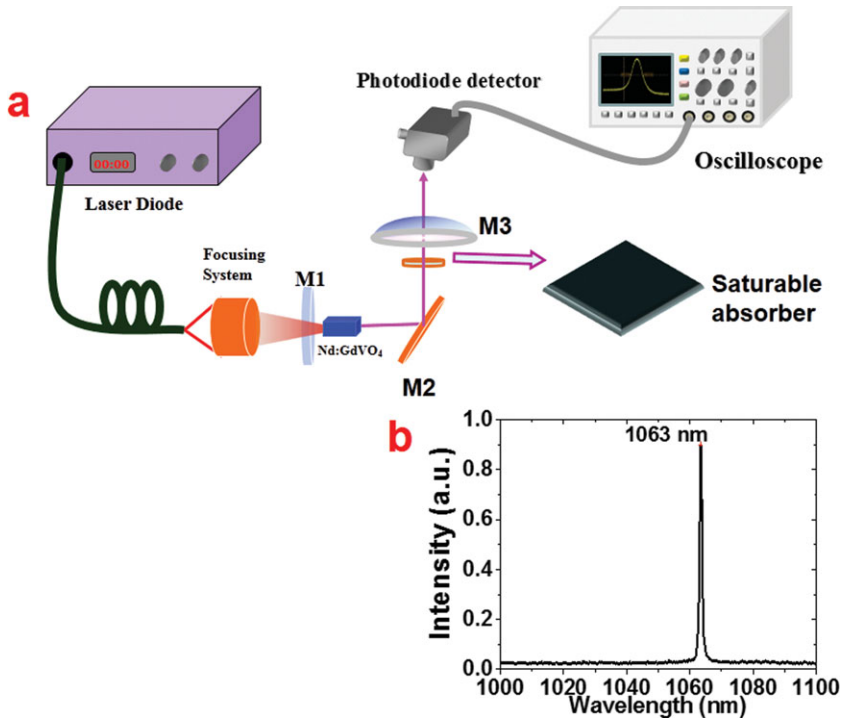


Figure 2 (a) Experimental setup of Nd:GdVO₄ pulsed laser. (b) Wavelength of the continuous-wave and pulsed lasers.

the topological insulator Bi₂Se₃ can be used as a broadband modulator in lasers with wavelengths shorter than 4.1 μm.

The X-ray diffraction (XRD) pattern is shown in Fig. 1b of Ref.17. This indicates that the Bi₂Se₃ sample used in the experiment has a rhombohedral structure (JCPDS card No.33-0214). The transmission spectrum of the sample is presented in Fig. 1d, which shows that the optical transmittance is about 68% over the wavelength range from 900 to 2500 nm. Considering the reflection of the quartz plate to be about 7%, the linear absorption of the sample is thus about 25%. The saturable absorption of Bi₂Se₃ induced by the imaginary part of the complex third-order susceptibility of the material is directly related to the photocarrier density. It can be described by the two-level saturable absorber model that is widely used for two-dimensional quantum wells and graphene:

$$\alpha^* = \frac{\alpha_s^*}{1 + \frac{N}{N_{\text{sat}}}} + \alpha_{\text{NS}}, \quad (1)$$

where α_s^* is the saturable and α_{NS} is the nonsaturable loss determined by the saturable and nonsaturable absorption coefficient, N is the photoinduced electron-hole density, and N_{sat} is the saturable density, which is the value of N where the absorption falls to one-half of its initial value. The photocarrier density can be simplified by introducing the incident light intensity (I) of a continuous-wave (cw) or long-pulse excitation as follows:

$$N = \frac{\alpha^* I \tau}{\hbar \omega}, \quad N_s = \frac{\alpha_s^* I_s \tau}{\hbar \omega}, \quad (2)$$

where τ is the carrier recombination time and ω is the light frequency. Under weak excitation, the absorption loss is $\alpha^* = \alpha_s^* + \alpha_{\text{NS}}$ and saturable absorption takes effect under

strong excitation. Based on previous investigations [22,23], the carrier interband scattering time in the Bi₂Se₃ bulk conduction band is about 0.5 ps, while the relaxation time for the Dirac cone nonequilibrium electrons to recover a Fermi-Dirac distribution of the surface states is over 10 ps. However, the surface states disperse into bulk states and the relaxation time of the Bi₂Se₃ charge carriers is thus mainly determined by interband scattering from the bulk conduction band whose recombination time is more efficient [23]. The saturable absorption can therefore be expressed as:

$$\alpha^* = \frac{\alpha_s^*}{1 + \frac{I}{I_{\text{sat}}}} + \alpha_{\text{NS}} \quad (3)$$

and the saturation intensity I_{sat} describing the saturable photoinduced electron-hole density is the degree of difficulty of being fully saturated and the most important parameter to consider for saturable absorption. With the relationship between absorption and transmission, the power-dependent nonlinear transmittance of the Bi₂Se₃ sample can be fitted with the following formula [14, 17]:

$$T = A \exp \left(\frac{-\delta T}{1 + \frac{I}{I_{\text{sat}}}} \right), \quad (4)$$

where T is the transmission, A is a normalization constant and δT is the absolute modulation depth. The power-dependent nonlinear absorption of the Bi₂Se₃ sample was investigated using a mode-locked Ti:Sapphire laser. Based on Eq. (4), the relation between the normalized optical transmittance and incident optical power is presented in Fig. 1e. The normalized transmittance increases nonlinearly with incident pump power, and the normalized

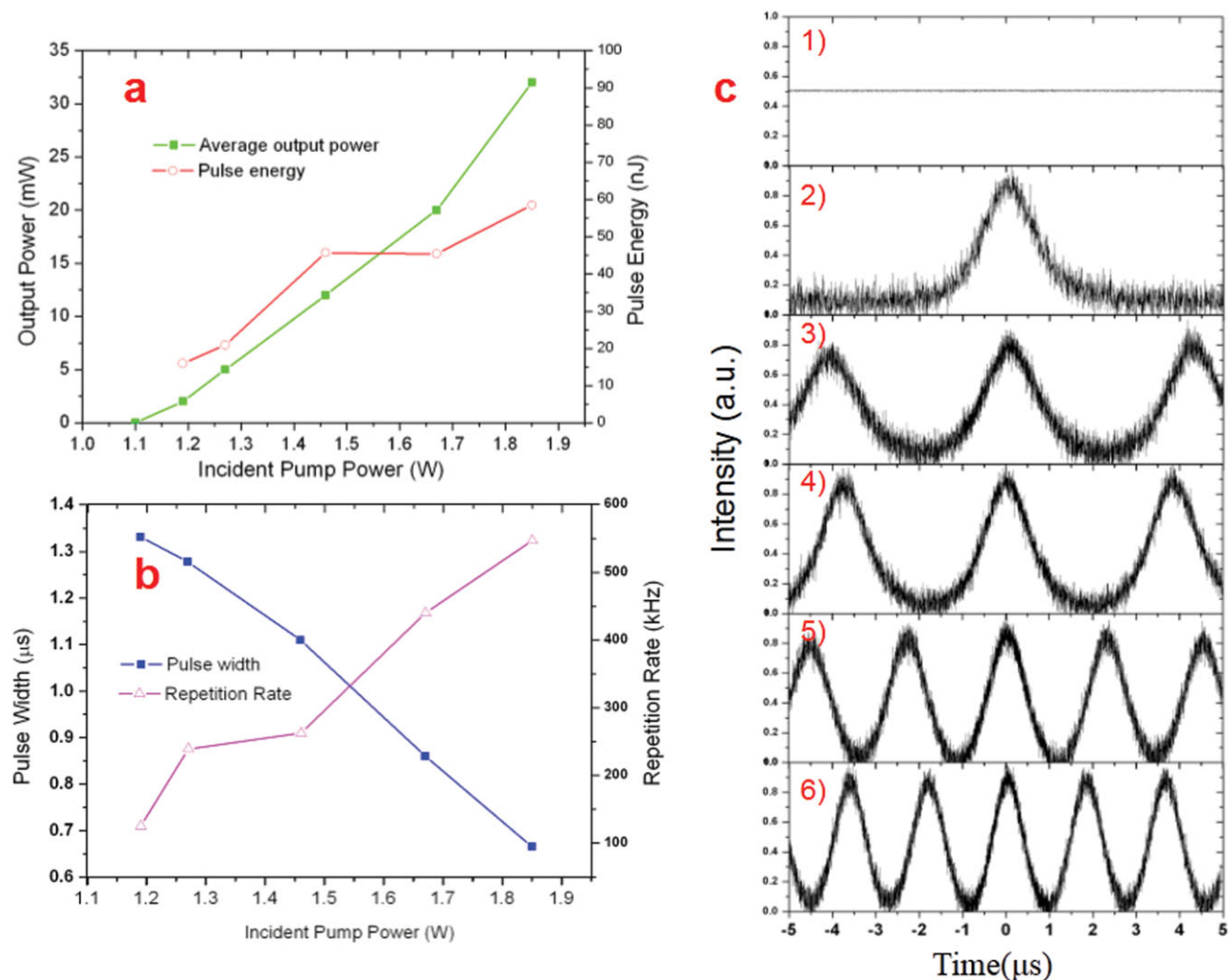


Figure 3 (a) Average output power and pulse energy vs. increasing incident pump power. (b) Pulse width and repetition rate vs. incident pump power. (c) Display recorded by digital oscilloscope for lasers. 1–6 Pulse profiles of continuous-wave Nd:GdVO₄ laser and pulsed lasers under pump power of 1.19 W, 1.27 W, 1.46 W, 1.67 W and 1.85 W, respectively.

modulation depth is 30%, which indicates that the Bi₂Se₃ sample exhibits saturable absorption. The saturation intensity was determined to be 4.3 GW/cm², a value that is much larger than that of graphene (0.71 to 0.61 MW/cm²) [15], which indicates that the topological insulator Bi₂Se₃ is difficult to fully saturate and is more favorable to generating large-energy pulses as a Q-switcher based on the analysis of passively modulated pulsed lasers [21].

2.2. Passively modulated laser

To avoid damage and the effects caused by the unabsorbed pump power on the sample, an L-shaped cavity was used for constructing the pulse laser. The experimental laser setup is sketched in Fig. 2a, and its detailed description is given in the Section 4. By removing the saturable absorber from the cavity, a cw Nd:GdVO₄ laser was realized. The digital oscilloscope trace shown in Fig. 3c1) displays the cw laser

emission. On inserting the saturable absorber into the laser cavity, passively Q-switched operation of the laser was obtained. The performance of the laser is shown in Fig. 3a. The Q-switching threshold was measured to be about 1.1 W and the output power increased quasilinearly with the pump power. The maximum output power reached 32 mW under an incident pump power of 1.85 W. The pulse width decreased, while the repetition rate increased with increase in the pump power, a result that is typical for a passively Q-switched laser [24]. The minimum pulse duration was 666 ns and the maximum repetition rate was 547 kHz. The variations of the pulse width and repetition rate with pump power are shown in Fig. 3b. Based on the measured average output power and repetition rate, the pulse energy was calculated, and shown in Fig. 3a. The maximum energy measured was 58.5 nJ.

Because the pulse energy increased with the incident pump power, we could conclude that the saturable absorber did not operate in the full-saturation regime, since the

oscillation intensity in the cavity remained low. Once the output power increased above 12 mW and the corresponding intracavity intensity reached a value higher than 60 mW, the pulse energy remained almost stable with respect to pump power, which suggests that the saturable absorber was almost totally saturated.

The digital oscilloscope trace of the laser output is displayed in Fig. 3c, and it can be seen that there were no pulse output by the cw laser. The pulse profile under a pump power of 1.19 W, 1.27 W, 1.46 W, 1.67 W and 1.85 W is shown in Figs. 3c 2–6, respectively. From this figure, it can be observed that the pulse trains were stable, the repetition rate increased with increasing pump power, and there was no mode locking. This result is different from what was observed in previous reports on fiber lasers [9]. It should also be noted that no thermal damage was observed on the surface of the topological insulator sample during the passively Q-switched laser operation, which indicates that a larger energy pulse can be modulated with Bi₂Se₃. From measurements with an optical spectrum analyser, the laser wavelength was found to be located at 1063 nm, as shown in Fig. 2b. Considering the previous results on fiber lasers at a wavelength of about 1.56 μm [17], the results presented here at a wavelength of 1.06 μm show that the topological insulator is also insensitive to excitation wavelength, as long as the wavelength is shorter than 4.1 μm. This result also demonstrates that the topological insulator can be used as a broadband optical material.

For passively Q-switched laser operation, the theoretical pulse width can be calculated using the following equation [25, 26]:

$$t = \frac{3.52T_R}{\Delta T}, \quad (5)$$

where, T_R is the cavity round-trip time, and ΔT is the modulation depth. For our experimental conditions, $T_R = 0.54$ ns, and therefore the maximum modulation depth ΔT is calculated to be less than 1%, which indicates that by increasing the modulation depth and improving the quality of the sample, the modulation properties of Bi₂Se₃ can be further improved.

3. Conclusions

A pulse bulk solid-state laser was constructed using a topological insulator, Bi₂Se₃ as the pulse modulator. These results demonstrate that the topological insulator is an effective broadband saturable absorber for pulse DPSSBLs with potential applications as broadband laser photonics. Comparative results on graphene, carbon nanotubes, and topological insulators for use as optical modulators in bulk lasers are shown in Table 1. By further optimizing the quality and modulation depth of the topological insulator, pulsed laser performance can be greatly improved. Besides promising applications in physics and computing, the easy fabrication and compactness in size, broadband modulation and the

Table 1 Comparative results on graphene, carbon nanotubes, and topological insulators as optical modulators in bulk lasers.

	Graphene					Carbon nanotube					Topological insulator				
	Wavelength					Wavelength					NA				
Mode-locking	0.8 μm	1 μm	1.5 μm	2 μm	2.5 μm	0.8 μm	1 μm	1.5 μm	2 μm	2.5 μm	0.8 μm	1 μm	1.5 μm	2 μm	2.5 μm
	63 fs (480 mW) [28]	160 fs (16 mW) [29]	91 fs (107 mW) [30]	410 fs (270 mW) [31]	226 fs (80 mW) [32]	62 fs (600 mW) [33]	100 fs (230 mW) [34]	92 fs [35]	175 fs (35 mW) [36]	NA	NA	666 ns (58.5 nJ) [This work]	NA	NA	NA
Q-switching	0.8 μm	1 μm	1.5 μm	2 μm	2.5 μm	NA					Wavelength				
	NA	56.2 ns (595.8 nJ) [37]	NA	1 μs, (1.74 μJ) [38]	NA	NA					Wavelength				

saturable absorption property augur a promising future in applications as an optoelectronic element.

4. Methods

4.1. Material preparation

The Bi₂Se₃ sample used in the experiments was synthesized via a polyol method [27]. The raw materials were Bi(NO₃)₃·5H₂O, sodium selenite, polyvinyl pyrrolidone and ethylene glycol, all of which were added into a two-neck flask containing a Teflon-coated magnetic stirring bar. The solution was dropped onto a quartz plate, and the plate was then placed inside a drying oven for evaporation for 8 h. The product was washed with isopropyl alcohol several times.

4.2. Laser design

For the laser experiments, we used an L-shape resonator (see Fig. 2). The pump power was delivered through the plane mirror (M1), antireflection (AR) coated for the pump wavelength of 808 nm, and highly reflective (HR) for the laser wavelength at about 1.06 μ m. The 45° folding mirror (M2) was a plane mirror, HR for the laser wavelength, and AR-coated for the pump radiation wavelength. M3 was the output coupler with a transmission of about 20% for the laser wavelength and a 100 mm radius of curvature. The length between M1 and M2 was 3.5 cm and the length between M2 and M3 was 4.6 cm. The pump source, a fiber-coupled, NA = 0.22, 200 μ m core diameter diode laser had an emission wavelength of 808 nm. The active element was a 8-mm thick, *a*-cut, 0.5 at.% Nd:GdVO₄ crystal with an aperture of 3 × 3 (along *c*) mm². The crystal surfaces were AR coated at 808 nm and 1.06 μ m. The crystal was mounted in a Cu holder with circulating water at 15 °C. The incident pump beam was focused to a 200- μ m spot diameter on the crystal with a focusing system.

The laser output power was measured by a power meter (EPM 2000, Molectron Inc.). The temporal behavior of the Q-switched laser was recorded by a TGS 3052 digital oscilloscope (500-MHz bandwidth and 2.5-Gs/s sampling rate, Tektronix Inc.). The laser spectrum was measured with an optical spectrum analyzer (HR4000CG-UV-NIR, Ocean Optics Inc.).

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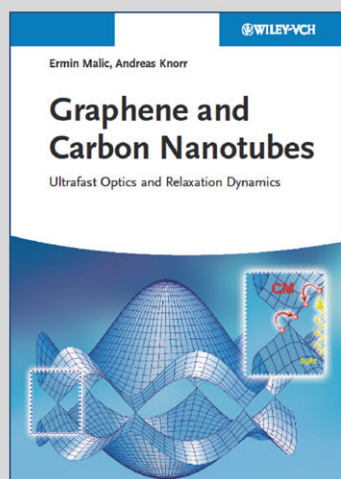
Key words: Topological insulator, saturable absorption, pulsed solid-state bulk laser, passively Q-switching.

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Graphene and Carbon Nanotubes*Ultrafast Relaxation Dynamics and Optics*

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